

Notice of References Cited	Application/Control No. 10/023,990	Applicant(s)/Patent Under Reexamination SEIBEL ET AL.	
	Examiner Kuen S. Lu	Art Unit 2167	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2004/0046021	03-2004	Chung, Kevin Kwong-Tai	235/386
*	B	US-6,250,548	06-2001	McClure et al.	235/51
*	C	US-4,776,510	10-1988	Jenkins, Richard A.	229/303
*	D	US-5,218,528	06-1993	Wise et al.	705/12
*	E	US-5,878,399	03-1999	Peralto, Ryan G.	705/12
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.